



Substitute for form 1449A/PTO (Modified) INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Complete if Known		
			Application Number	09/491,429	
			Filing Date	January 26, 2000	
			First Named Inventor	John F. HEANUE	
			Art Unit	2828	
			Examiner Name	Rodriguez, Armando	
Sheet	1	of	5	Attorney Docket Number	A-68918/ENB (468880-00007)

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
AR	A1	4,460,977	07-14-1984	Shimada et al.	
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AR	A4	4,583,227	04-15-1986	Kirkby	
AR	A5	4,770,047	09-13-1988	Arditty et al.	
AR	A6	4,839,614	06-13-1989	Hill et al.	
AR	A7	4,843,233	06-27-1989	Jeunhomme	
AR	A8	4,847,854	07-11-1989	Van Dijk	
AR	A9	4,870,269	09-26-1989	Jeunhomme et al.	
AR	A10	4,932,782	06-12-1990	Graindorge et al.	
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AR	A12	5,028,395	07-02-1991	Sebille et al.	
AR	A13	5,050,179	09-17-1991	Mooradian	
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AR	A19	5,163,063	11-10-1992	Yoshikawa et al.	
AR	A20	5,172,185	12-15-1992	Leuchs et al.	
AR	A21	5,181,078	01-19-1993	Lefevre et al.	
AR	A22	5,181,214	01-19-1993	Berger et al.	
AR	A23	5,181,717	01-26-1993	Donntag et al.	
AR	A24	5,185,643	02-09-1993	Vry et al.	
AR	A25	5,218,610	06-08-1993	Dixon	
AR	A26	5,225,930	07-06-1993	Land et al.	
AR	A27	5,263,037	11-16-1993	Trutna, Jr. et al.	
AR	A28	5,270,791	12-14-1993	Lefevre et al.	
AR	A29	5,305,330	04-19-1994	Rieder et al.	
AR	A30	5,321,717	06-14-1994	Adachi et al.	

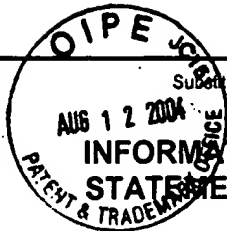
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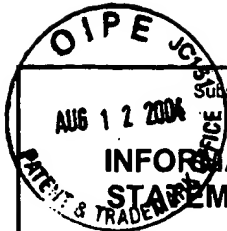
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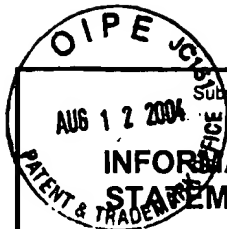
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NON PATENT LITERATURE DOCUMENTS						
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				T ⁶
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